

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hidekazu MORIYAMA

Application No.: 10/827,426

Filed: April 20, 2004

Examiner:

W. FLETCHER

Docket No.: 119295

Group Art Unit: 1792

CLEANING METHOD, STORAGE METHOD, PATTERN FORMATION METHOD,

DEVICE MANUFACTURING METHOD, ELECTRO-OPTICAL DEVICE, AND

ELECTRONIC APPARATUS

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In reply to the April 9, 2008 Restriction Requirement, Applicant provisionally elects Group I, claims 1-5, with traverse.

It is respectfully submitted that the subject matter of all claims 1-14 is sufficiently related that a thorough search for the subject matter of any one Group of claims would encompass a search for the subject matter of the remaining claims. Thus, it is respectfully submitted that the search and examination of the entire application could be made without serious burden. See MPEP §803 in which it is stated that "if the search and examination of an entire application can be made without serious burden, the examiner must examine it on the merits, even though it includes claims to independent or distinct inventions" (emphasis added). It is respectfully submitted that this policy should apply in the present application in order to avoid unnecessary delay and expense to Applicant and duplicative examination by the Patent Office.

Thus, withdrawal of the Restriction Requirement is respectfully requested.

Respectfully submitted,

James A. Oliff

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JAO:SQV/jcp

Date: May 6, 2008

OLIFF & BERRIDGE, PLC P.O. Box 320850 Alexandria, Virginia 22320-4850 Telephone: (703) 836-6400 DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry;

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